

Title (en)  
Surface washing device

Title (de)  
Oberflächenreinigungsvorrichtung

Title (fr)  
Dispositif de nettoyage de surfaces

Publication  
**EP 1775032 A1 20070418 (DE)**

Application  
**EP 06015733 A 20060728**

Priority  
DE 102005049473 A 20051013

Abstract (en)  
The device has a cleaning chamber (2) that is adapted to receive goods to be cleaned. A tank (6) is provided for receiving a cleaning medium (5), and a supply device is provided in the cleaning chamber. The supply device conveys the cleaning medium from the tank to the chamber. A return device is arranged for returning the cleaning medium from the chamber to the tank. An analysis device (10) measures contamination of the medium.

IPC 8 full level  
**B08B 3/00** (2006.01)

CPC (source: EP US)  
**B08B 3/00** (2013.01 - EP US)

Citation (applicant)  
• US 2004238005 A1 20041202 - TAKAYAMA KAZUHISA [JP]  
• DE 19609783 A1 19970918 - MEISSNER WERNER [DE]  
• DE 19745428 A1 19980514 - HONEYWELL INC [US]  
• WO 8801737 A1 19880310 - PERREN BENNO [CH]

Citation (search report)  
• [X] US 2004238005 A1 20041202 - TAKAYAMA KAZUHISA [JP]  
• [A] DE 10156924 A1 20030605 - BHT HYGIENE TECHNIK GMBH [DE]

Designated contracting state (EPC)  
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IS IT LI LT LU LV MC NL PL PT RO SE SI SK TR

Designated extension state (EPC)  
AL BA HR MK YU

DOCDB simple family (publication)  
**EP 1775032 A1 20070418; EP 1775032 B1 20100707**; AT E473058 T1 20100715; DE 102005049473 A1 20070419;  
DE 102005049473 B4 20090827; DE 502006007367 D1 20100819; US 2007084487 A1 20070419

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**EP 06015733 A 20060728**; AT 06015733 T 20060728; DE 102005049473 A 20051013; DE 502006007367 T 20060728;  
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